

**Attorney Docket No.: FUJI 20.624 (100794-00480)**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s): Hitoshi YAMADA et al.  
Confirmation No.: 1140  
Serial No.: 10/657,747  
Filed: September 8, 2003  
Title: **RESOURCE LOAD MEASURING METHOD ...**  
Examiner: Kamal B Divecha  
Group Art Unit: 2151

April 18, 2008

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

SIR:

In response to the non-final Office Action dated January 18, 2008, Applicants respectfully submit the following: